

1 **Progress in plasma-based doping semiconductor photocatalysts for efficient**
2 **pollutant remediation and hydrogen generation**

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19 **Research highlights:**

20 ➤ Plasma-based doping of composite materials was an efficient way to reduce the band gap.

21 ➤ Plasma-based doping promoted substitutional doping.

22 ➤ Different methods for plasma discharge for doping were discussed.

23 ➤ Limited studies were performed on the real-life applications of plasma-based materials.

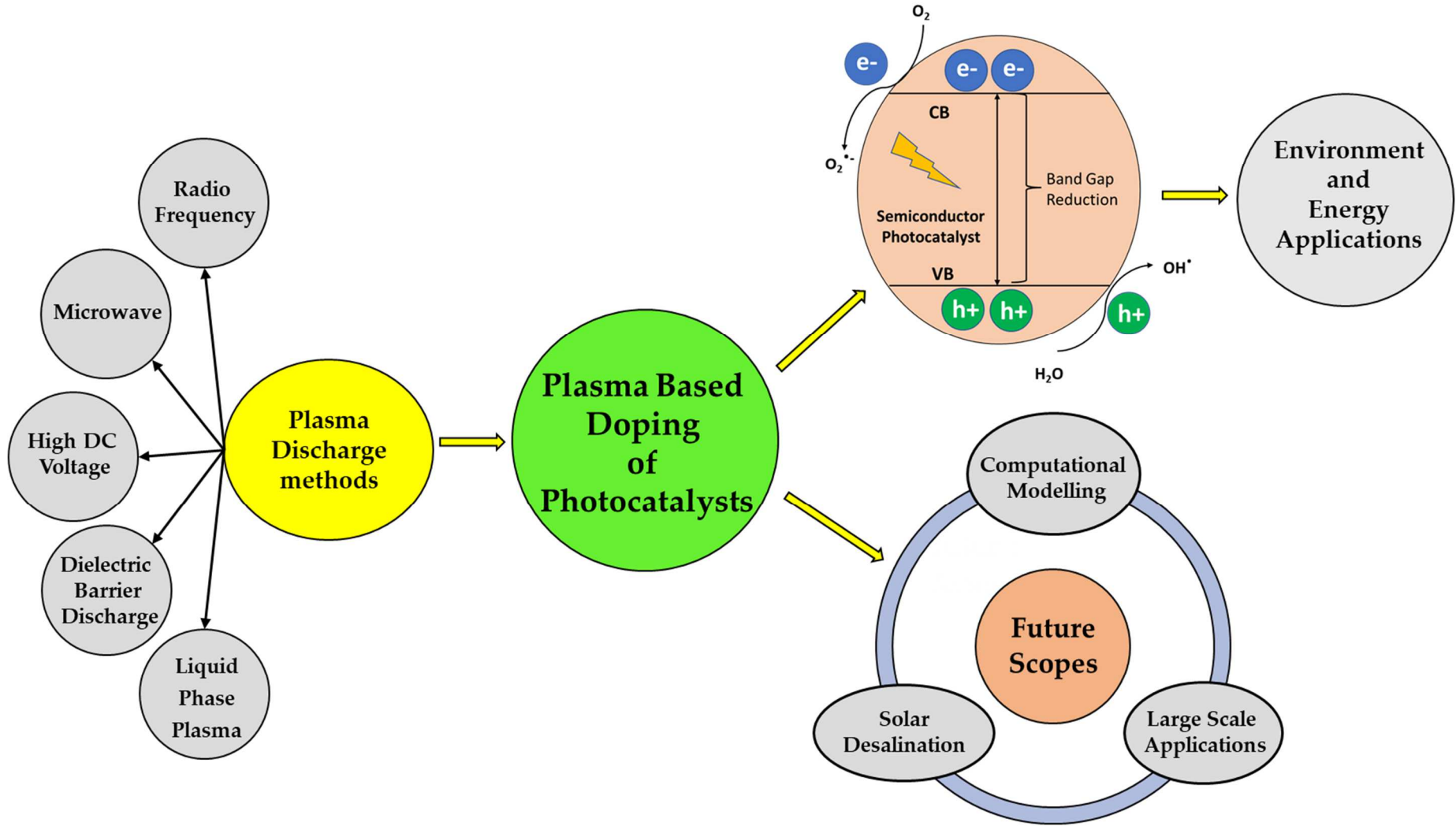
24 ➤ An in-depth understanding of the mechanisms was required for computational modelling.

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27 **Graphical Abstract**

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45 **Abstract**

46 In recent years, solar energy-driven photocatalysis materials have drawn significant
47 attention to addressing the global energy and environmental crisis. However, many of the
48 semiconductor photocatalysts are unable to absorb the visible light of the solar spectra due to
49 their wide band gap. The incorporation of a foreign element such as a dopant in the lattice of
50 these photocatalysts was shown to reduce their band gap and enhance visible light absorption.
51 The doping of semiconductors can be performed using several techniques such as sol-gel,
52 hydrothermal, solvothermal, and plasma-based doping. However, plasma-based doping has
53 been considered a highly efficient approach due to the reduction of the band gap to a large
54 extent, enhancement of visible light absorption, and remarkable photocatalytic activities
55 under visible light illumination. The plasma-based doping approach offered many advantages
56 such as high reactivity, process simplicity, scalability, energy efficiency, homogeneous
57 doping, no chemical inventory, low pressure, and low-temperature operation, and flexibility
58 of operation under gas and liquid phase media. Further advancement of plasma-based doping
59 can be achieved through more theoretical studies allowing an in-depth understanding of the
60 mechanisms and interactions of the species involved. This will facilitate the synthesis and
61 application of doped photocatalysts in a cost-effective manner. This review surveyed recent
62 advances in a wide range of semiconductor photocatalysts doped with various dopants using
63 plasma treatment. Various plasma methods for doping semiconductor photocatalysts and their
64 fundamental mechanisms were discussed. The performance characteristics of the plasma-
65 doped photocatalysts were compared to other methods in terms of energy and environmental
66 applications including degradation of environmental contaminants and solar fuel production
67 such as hydrogen production from water splitting using visible light-driven solar energy.
68 Finally, potential future research directions were recommended for the applications of the
69 efficient photocatalysts developed by plasma treatment.

70 **Keywords:** Photocatalysis; Plasma doping; Band gap; Environmental remediation; Hydrogen
71 production.

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73 **1. Introduction**

74 Currently, the world faces a great challenge in terms of environmental sustainability
75 and energy security [1]. Consumption of fossil fuels for energy production increases
76 environmental pollution through carbon emissions, and their continual depletion poses a huge
77 threat to the global community [2,3]. Furthermore, with industrial progress, hazardous
78 industrial waste disposals are growing, posing a huge concern for the environment [4–8]. As
79 a result, efforts are being made to explore technologies for better utilization of renewable
80 energy sources and environmental remediation [9–11].

81 Solar energy-driven photocatalysis is a promising approach to solving the existing
82 energy crisis and encountering environmental remediation. Photocatalysis is the process of
83 generation of electron-hole pairs that take part in redox reactions upon the incidence of
84 photons [12]. These redox reactions produce radicals that take part in H₂ production via water
85 splitting, degradation of bio-persistent organic pollutants, CO₂ reduction, disinfection, and
86 other applications [13–15]. Semiconductors are favorable for photocatalysis due to their band
87 gap between the conduction band and valence band being a few electron volts, and band
88 energy alignment with the photocatalytic reactions [16]. The reaction mechanism of
89 photocatalysis involves the generation of electrons and holes upon the illumination of visible
90 and UV light if the incident photon energy is higher than the band gap energy of the
91 photocatalyst. the excited positive charges in the valence band oxidize H₂O to form hydroxyl
92 radical ([•]OH) while the conduction band electron reduces with pure O₂ to produce superoxide
93 anion radicals (O₂^{•-}). These strong oxidative species are utilized in the photocatalytic

94 degradation process and form mineralized products such as carbon dioxide (CO₂), water
95 (H₂O), and other minerals [17–19]. Recently, several semiconductor photocatalysts including
96 TiO₂ [17], WO₃ [18], CdS [20], Bi₃NbO₇ [21], ZnO [22], Cu₂O [23], CdO [24], SnO₂ [25],
97 Al₂O₃ [26], SiO₂ [27], Fe₂O₃ [28], etc. have been employed for different photocatalytic
98 applications because of their enhanced chemical stability, stable electronic structure, and
99 potential chemical and physical properties [29]. Typically, the photocatalytic activity is
100 attributed to increasing visible light harvesting and decreasing the recombination of
101 photogenerated charge carriers [30]. Moreover, due to the formation of the heterostructure,
102 the narrow band gap semiconductors enhance the charge separation and reduce the
103 recombination rate of the photogenerated electron-hole, improving the photocatalytic
104 performance [28, 31–33]. Numerous approaches have been employed to synthesize
105 semiconductor photocatalysts such as sol-gel methods, physical vapor deposition, chemical
106 vapor deposition, chemical precipitation method, spray pyrolysis, microwave-induced plasma
107 technique, solvothermal method, sonochemical method, wet impregnation method, ultrasound
108 impregnation method, hydrothermal method, etc. Each method has specific advantages and
109 disadvantages over the reaction conditions, calcination process, and reactor configuration
110 [34–37]. However, the conventional methods suffer from different disadvantages like high
111 recombination rate, low visible light utilization efficiency, smaller surface area, and pore
112 volume which inhibit their practical application. To address these difficulties, a significant
113 effort has been invested in the development of photocatalysts through suppressing electron-
114 hole pairs, enhancing light absorption capacity, semiconductor coupling, creating point
115 defects, copolymerization, plasma doping, and doping/co-doping of metals/non-metals for
116 improving photocatalytic performance [38]. Doping of photocatalysts can be effective in
117 reducing the band gap causing a redshift of absorption edge for its utilization under solar
118 irradiation. Doping of ions can introduce an additional energy level that can trap the excited

119 hole or electron reducing the recombination and enhancing charge carrier separation. Also, it
120 can introduce surface defects and oxygen vacancies allowing the reduction of the bandgap.
121 Doping has been found to reduce the band gap allowing photocatalytic activity under visible
122 irradiation, and modification of surface and morphological properties [39]. There are various
123 doping methods including sol-gel [40], chemical vapor deposition (CVD) [41], physical
124 vapor deposition (PVD) [42], hydrothermal [43], and plasma doping [44].

125 Recently, plasma doping has received greater attention among doping methods from
126 researchers because it is a rapid, facile, and energy-efficient technique. It is widely used in
127 bandgap reduction by inducing defects within the semiconductor photocatalyst allowing
128 enhanced photocatalytic activity [45]. Generally, plasma is a special type of state which
129 consists of a huge number of electrons, photons, free radicals, energetic ions, excited
130 molecules, atoms, and other particles. In the following step, it can be able to initiate a large
131 number of reactions effectively resulting in enhanced surface defects and controlled doping
132 [29,46]. The microwave region (2.45 GHz) has widely been used as the major source which
133 is more readily available. Plasma is formed inside and outside of the bubble's boundary in the
134 liquids whereas bubbles are continuously formed during plasma generation [34].
135 Furthermore, plasma does not influence the structure of photocatalyst but changes its
136 morphology, introduces active functional groups, improved surface area, and pore volume,
137 increases the hydrophilicity, decreases the bandgap energy, and enhances the separation
138 efficiency of photogenerated electrons/holes and thus consequently increases photocatalytic
139 activity facilitating energy and environmental application [29,47,48]. Studies have shown
140 improved photocatalytic activity by utilizing various types of plasma operating conditions
141 like nitrogen, hydrogen, air, oxygen, and argon. In a recent study, Ramos-Corona et al.
142 (2022) synthesized N-doped ZnO supported on sheets of graphene oxide for the degradation
143 of lignin. They used N₂-plasma discharge for N-doping. They found a reduced band gap

144 resulting in enhanced photocatalytic activity due to plasma doping [49]. In another study,
145 Zhang et al. (2020) demonstrated enhanced transfer and separation of photogenerated charge
146 carriers by applying plasma doping for synthesizing N-doped Cu₂O@CuO heterostructure
147 [45]. The effect of H₂-plasma doping on the photocatalytic activity of TiO₂ was investigated
148 by Yan et al. (2014). The surface defects induced by H-doping resulted in enhanced
149 degradation of MB [50]. It was reported that the plasma doping using O₂-plasma modified the
150 surface morphology, increasing the BET surface area and reducing band gap energy, resulting
151 in enhanced adsorption of rhodamine blue (RhB) dye by g-C₃N₄ prepared with a
152 hydrothermal technique under anoxic conditions [29]. In another study, Bootluck et al. (2021)
153 demonstrated that the formation of oxygen vacancies and Ti³⁺ was improved by the Ar-
154 plasma treatment of α-Fe₂O₃/TiO₂. This resulted in enhanced photocatalytic performance
155 under visible light illumination [51]. On the other hand, the air plasma treatment of Fe/Co-
156 doped TiO₂ thin films improved their optical absorbance through the formation of Ti³⁺ and
157 oxygen vacancies [52].

158 Although researchers are actively working on several aspects of plasma-doped
159 photocatalysts, a compiled and structured review work in this area is unavailable. Therefore,
160 the production of scattered and non-directional investigative works is dominating in this area.
161 With the goal of solving this issue, in this review, we have summarized the advantages and
162 drawbacks of different doping methods concerning plasma doping. An in-depth discussion on
163 the plasma doping mechanisms was studied to present the holistic idea of plasma doping.
164 Extensive research has been performed on environmental remediation and energy
165 applications using several types of plasma doping. The modeling of the plasma doping area
166 was also investigated based on the literature search. However, a few challenges have been
167 identified by critically reviewing the literature, and the authors have suggested some future
168 recommendations. Finally, the author hopes that this review paper will help find out more

169 about various types of plasma doping based on their reactor design, reaction conditions,
170 performance, and applications in future research work.

171

172 **2. Comparative analysis of different doping methods**

173 Several limitations of undoped photocatalysts include insufficient utilization of visible
174 light, high electron-hole recombination, low pollutant degradation, poor thermal stability, and
175 difficulties in the recovery of nanoparticles along with the aggregation of nanoparticles [53].
176 The photocatalytic properties can be enhanced by doping with metal or non-metal atoms or
177 molecules. Doping enhances photocatalytic activity by narrowing the band-gap energy of the
178 nanoparticles and expanding their activity to the visible region. Various methods employed
179 for doping purposes, e.g., PVD, CVD, sol-gel, hydrothermal, spray pyrolysis, and plasma
180 doping, are represented in **Table 1**. These methods vary in terms of mechanism, cost,
181 chemical, and energy requirement, quality of produced doped photocatalysts, the extent of
182 band gap reduction, etc. Conventional doping methods are effective yet require a substantial
183 amount of chemicals, time, and energy. One of the significant challenges of doping at bulk
184 and nanoscale is that the dopant atoms fail to be incorporated within the nanocrystal lattice
185 and instead get adsorbed on the surface. This is because the defects are thermally unstable
186 and are diffused to the surface of the nanocrystal at the time of growth; in other words,
187 known as self-purification. Another challenge is the inhomogeneous dopant concentration
188 among the nanocrystal [54].

189 Li et al., (2015) investigated the nitrogen doping of TiO₂ (N-TiO₂) by the sol-gel
190 method [55]. The preparation of N-TiO₂ took 5 days and calcination at 600 °C removed the
191 doped nitrogen. Than *et al.*, (2017) also studied N-TiO₂ by sol-gel method, and the bandgap
192 energy was reduced to 2.71 eV [56]. In both cases, the preparation of the photocatalyst was
193 time-consuming and required the use of many chemicals [55,56]. Sarantopoulos et al., (2009)

194 reported nitrogen-doped TiO₂ by chemical vapor decomposition which resulted in low
195 crystallinity, photo-inactivity, and surface defects at 300-350°C calcination. The bandgap
196 energy was reduced to 3.00-3.05 eV from 3.25 eV [41]. In the case of nitrogen doping for the
197 same semiconductor photocatalyst using plasma doping, Islam et al., 2016 reported that the
198 60-120 min of plasma treatment in nitrogen-doped ordered mesoporous TiO₂ thin film can
199 reduce the bandgap energy 3.5 eV to 2.88 eV. The colorless undoped titania turned into
200 yellow-colored film after plasma treatment and their visible light absorption significantly
201 increased with the redshift of the spectrum (**Fig. 1**). X-ray photoelectron spectroscopy (XPS)
202 suggests that the amount of nitrogen doping in the titania films was about 4.5 atomic % and
203 the doping occurred uniformly across the film thickness. The state of nitrogen in the titania
204 film was substitutional, meaning that the oxygen atom was replaced by the nitrogen atom in
205 the titania lattice. It was suggested that the true band gap is reduced by substitutional doping
206 which was achieved by the plasma treatment. Furthermore, as shown in **Fig. 1**, titania film
207 maintained its nanostructure after the plasma treatment as shown in the scanning electron
208 microscopy (SEM) images (**Fig. 2**). The plasma-treated nitrogen-doped titania films were
209 evaluated by methylene blue degradation using visible light illumination. The doped films
210 degraded methylene blue about 6 times faster than the undoped titania films under visible
211 light illumination. The same group further optimized the plasma processing parameters
212 including power, pressure, and nitrogen gas flow rate into the plasma reactor to obtain the
213 best doping performance. The doped nanostructured titania films were applied to produce
214 hydrogen gas from photoelectrochemical water splitting using visible light of the solar
215 energy. About 200 times higher photocurrent was obtained for plasma-treated titania
216 compared to the undoped titania films under UV-LED, Blue-LED, and Green LED light
217 illumination (**Fig. 3**). The results suggest that plasma treatment in the nanostructured titania

218 films has a profound impact on its visible light absorption and has shown remarkable
219 performance in photocatalytic performance.

220 Islam et al., (2016) also reported doping of nitrogen in ordered mesoporous titania
221 films using hydrazine as a chemical precursor for nitrogen [57]. The nanostructured titania
222 films were exposed to hydrazine for about 20 hours. Although nitrogen was doped in
223 nanostructured titania films, XPS showed interstitial doping and a reduced bandgap of 3.3 eV
224 from 3.5 eV. The amount of nitrogen-doped in titania was about 1.0 - 2.0 atomic%. The
225 results suggest that compared to the chemical method, plasma-based doping showed
226 significantly higher photocatalytic performance. The results suggest that plasma-based
227 doping is much more efficient than wet chemical-based doping in nanostructured titania
228 photocatalysts. As shown in **Table 1**, the plasma doping method for the same N-TiO₂ catalyst
229 requires less time and chemicals compared to the aforementioned methods [44,58, 116-121,
230 124-127].

231 In addition to improving photoactivity, plasma doping has great economic potential
232 for large-scale applications compared to other methods. The cost of plasma doping mainly
233 involves fixed and operational costs. The fixed expenses mainly include the cost of the
234 plasma reactor and overall setup. On the other hand, the operating costs include the cost of
235 energy and dopants used in the discharge [59–61]. The enhanced photoactivity of the plasma-
236 doped photocatalysts should be taken into account while assessing the economic potential of
237 the process. Compared to other techniques, the plasma doping method is cost-effective as it
238 does not require any catalysts, surfactants, and other chemicals. It only requires dopant
239 precursors. Furthermore, plasma doping using nonthermal plasma is a fast, flexible energy-
240 efficient, and sustainable process [61,62]. The plasma reactor can be optimized by tuning the
241 operating parameters for achieving controlled doping. With further modifications, higher
242 yield and reduction of cost can be achieved by scaling up the plasma reactor [46]. In spite of

243 having great economic potential compared to other processes, there has been no study
244 conducting the economic analysis of plasma-doped photocatalysis. As a result, there is a
245 scope for investigation regarding the economics of the plasma-doping method in order to
246 assess its application on a large scale.

247 Plasma doping is not only effective but also overcomes the difficulties associated with
248 the other methods. Doping using plasma produces a more homogeneous distribution of doped
249 materials and energy. It also reduces doping time owing to the single-step treatment and
250 causes less consumption of chemicals, thus decreasing cost. However, all types of plasma
251 doping methods do not provide the same benefits. For instance, the nanostructure of many
252 photocatalysts may not be completely stable under thermal plasma conditions. Non-thermal
253 plasma is easier to handle, relatively safer, environmentally friendly, and cheaper compared
254 to thermal plasma [63]. It also maintains the nanostructure of the photocatalyst due to low-
255 temperature treatment [58]. Regardless of the differences between various plasma doping
256 methods, plasma generally produces more uniform doping, higher degradation and reaction
257 rate, and higher substitutional dopant on the surface of the nanocrystal [64,65]. Therefore,
258 plasma doping can be considered a better approach compared to other conventional methods.

259

260 **3. Plasma-Based Doping of Semiconductor Photocatalysts**

261 Plasma is known as the fourth state of matter containing excited electrons, ions,
262 radicals, and photons. It is formed when the atoms of the dopant obtain sufficient energy such
263 that the electrons are released from the atoms. As a result, positive nuclei and free electrons
264 are formed in the gaseous state. This ionized state is electronically neutral due to the presence
265 of an equal number of electrons and positively charged nuclei. The plasma thus formed is
266 highly reactive compared to the gaseous state of the dopant which enhances the doping

267 efficiency of the atoms in the photocatalyst [9]. In addition to thin films, photocatalyst
268 powder or nanotube arrays can also be plasma-doped [58]. If enough energy is available,
269 plasma doping can also be carried out in both liquid and gaseous phases. It is mainly done in
270 a vacuum or low pressure.

271

272 **3.1. Mechanism of Plasma Doping**

273 For the deposition of dopants or doping by plasma, the fast-moving electrons collide
274 with the particles. These collisions can be elastic or inelastic. When an inelastic collision
275 occurs, it causes a change in the potential of the particles. As a result, excitation, ionization,
276 and dissociation of the particles occur, as shown in **Fig. 4**.

277 In this situation, the plasma reaches a quasi-neutral condition. The region between the
278 plasma and the substrate or thin film is known as the sheath region. In the positively charged
279 sheath region, the neutral species migrate by diffusion and the ionized particles accelerate
280 through the sheath layer to reach the thin film where it is bombarded to cause reaction,
281 adsorption, and dissociation. For doping, these high-energy particles take the interstitial
282 spaces and cause surface defects on the photocatalyst to which they are to be doped. The by-
283 products formed are desorbed from the surface [66]. In the case of plasma doping with
284 nitrogen, precursors such as NH_3 , and N_2 are used. An inert gas such as Ar is also utilized
285 with the precursors for the creation of oxygen vacancy allowing substitutional doping of
286 nitrogen atoms [51]. Furthermore, it can take part in the penning ionization process by the
287 metastable Ar atoms [67]. Moreover, argon helps in igniting the plasma before introducing
288 the dopant species such as nitrogen. Using NH_3 as a precursor, Chen et al., (2019)
289 synthesized N-doped TiO_2 using cold Dielectric Barrier Discharge (DBD) plasma. It was
290 found that both substitutional and interstitial doping of N occurred because of DBD plasma
291 which is evident from the XPS results as shown in **Fig. 5** [67].

292 The optical emission spectra showed the formation of reactive species in the plasma
 293 including NH and N₂⁺ radicals. The concentration of N in TiO₂ is found to increase as the
 294 concentration of NH₃ and power increase. Since the amount of N in TiO₂ is dependent on the
 295 NH radical formation, the NH formation is reduced at a high concentration of NH₃ due to its
 296 decomposition to H[•] and NH[•] [58], [59]. They proposed that the reactions take place allowing
 297 the formation of NH radicals as shown below [67–70]:

298 Ionization and Excitation Reactions:

$e^- + \text{NH}_3 \rightarrow \text{NH}_3^* + e^-$	(1)
$e^- + \text{NH}_3 \rightarrow \text{NH} + 2\text{H} + e^-$	(2)
$\text{NH}_3^* + e^- \rightarrow \text{NH} + 2\text{H} + e^-$	(3)
$e^- + \text{NH}_3 \rightarrow \text{NH}_3^+ + 2e^-$	(4)
$e^- + \text{NH}_3^* \rightarrow \text{NH}_3^+ + 2e^-$	(5)

299

300 Penning Reaction with Argon:

$\text{Ar} + \text{NH}_3 \rightarrow \text{NH}_3^+ + \text{Ar} + e^-$	(6)
$\text{Ar} + \text{NH}_3 \rightarrow \text{NH}_2 + \text{Ar} + \text{H}$	(7)
$\text{Ar} + \text{NH}_3 \rightarrow \text{NH} + \text{Ar} + \text{H} + \text{H}$	(8)

301 Binary and Three-body reaction:

$\text{NH}_2 + \text{Ar} + \text{H} \rightarrow \text{Ar} + \text{NH}_3$	(9)
$\text{NH}_2 + \text{NH}_2 + \text{Ar} \rightarrow \text{Ar} + \text{N}_2\text{H}_4$	(10)
$\text{go} + \text{H} + \text{H} + \text{Ar} \rightarrow \text{Ar} + \text{NH}_3$	(11)
$\text{H} + \text{H} + \text{Ar} \rightarrow \text{Ar} + \text{H}_2$	(12)
$\text{NH} + \text{NH} \rightarrow 2\text{H} + \text{N}_2$	(13)
$\text{NH}_2 + \text{N} \rightarrow 2\text{H} + \text{N}_2$	(14)

302

303 Studies have also shown the plasma doping of N into the lattice of TiO₂ using an N₂
 304 precursor. The reactions for N₂ plasma are simple with the formation of the excited state of
 305 nitrogen and radicals and are as follows:

Excitation Reaction: $N_2 + e^- \rightarrow N_2^* + e^-$	(15)
Radical Formation: $N_2^* + e^- \rightarrow N + N + e^-$	(16)

306
 307 Islam et al., (2016) observed that N₂/Ar plasma-treated TiO₂ contained a larger
 308 amount of substitutional N bond in the lattice from XPS results [58]. This can be attributed to
 309 the application of Ar and plasma doping, which causes oxygen vacancies in the lattice and
 310 allows the production of a more intense substitutional XPS peak compared to other doping
 311 techniques, hence enhancing the photocatalytic activity compared to other techniques.

312

313 3.2 Properties of plasma doped photocatalysts

314 Plasma-doped photocatalyst shows enhanced photocatalytic activity. The
 315 enhancement of photoactivity is mainly achieved by the reduction of the band gap. Plasma
 316 treatment of photocatalysts allows the increase of oxygen vacancies and introduces defects
 317 within the structure of the catalyst [52,71].

318 Oxygen vacancies generated in metal oxides through plasma doping can play a
 319 significant role in enhancing photoactivity. It has an enormous impact on the photocatalytic
 320 redox reactions. It can control light absorption and charge separation by forming defective
 321 sites and lattice distortion [72,73]. It can create new defect levels allowing a downward shift
 322 of the conduction band and an upward shift of the valence band. As a result, the band gap is
 323 narrowed which allows enhanced photocatalytic activity under solar irradiation. Oxygen

324 vacancies can also control the transfer of charges and recombination rate. It can trap electrons
325 by acting as positive charge centers inhibiting the recombination of electron-hole pairs [74].
326 However, excessive oxygen vacancies can trap more electrons and inhibit their movement.
327 As a result, the excessive formation of oxygen vacancies can lead to a reduction in
328 photocatalytic performance [75]. Plasma doping can prevent excess oxygen vacancy
329 formation as it is controllable and allow proper distribution of defects throughout the catalyst
330 surface [46]. Other than that, oxygen vacancies can enhance the adsorption of molecules and
331 control the kinetics of photocatalytic reactions. Oxygen vacancies formed due to plasma
332 allow substitution doping. Several characterization techniques including XPS, Raman
333 spectroscopy, Electron Paramagnetic Resonance (EPR), Scanning Transmission Electron
334 Microscopy (STEM), etc. and can be used to investigate oxygen vacancies [72]. The
335 substitutional doping can increase the photoactivity of the nanocomposites as shown in the
336 previous section. Plasma doping has also been shown to increase the surface area and
337 modifier of surface morphology of the catalyst resulting in more active sites for
338 photocatalytic reaction.

339

340 **4. Plasma Discharge Methods**

341 Various types of plasma can be used for doping photocatalysts. The plasma doping
342 methods include (i) plasma enhanced chemical vapor deposition (PECVD), (ii) liquid phase
343 plasma (LPP), (iii) arc discharge, (iv) ion implantation, (v) corona discharge, (vi) microwave
344 plasma discharge (MPD), (vii) radio frequency plasma discharge (RFPD), and (viii) DBD.
345 Each of the mentioned methods has both advantages and disadvantages that keep their
346 significance distinct from each other. It is possible that sometimes one method can be suited
347 better for a certain photocatalyst whereas others cannot be used effectively. For example,
348 because of high energy consumption, and low yield, the arc discharge method cannot be used

349 industrially whereas, CVD can overcome those shortcomings [76]. All the methods have
350 different applications based on their modification properties. The arc discharge is used for
351 fuel conversion, whereas corona discharge is used not only for fuel conversion but also for
352 combustion. PECVD is mostly used for passivation, DBD for the main basic research study,
353 and, MPD and RFPD for syngas production.

354

355 **4.1 Radio Frequency based plasma**

356 In the case of radio-frequency (RF)-based plasma, the plasma is generated using a
357 radio frequency of 13.65 MHz [76,77]. It uses two electrodes including RF biased electrode
358 and a ground electrode. The RF-biased electrode is connected to the RF power source
359 through an impedance-matching network [78]. The plasma remains in the space between the
360 two electrodes. Depending on the coupling of the power source to the plasma, there can be
361 two types of discharge namely, Capacitively Coupled Plasma (CCP) and Inductively Coupled
362 Plasma (ICP). In plasma doping applications, ICP is used more compared to CCP. The ICP is
363 more suitable for semiconductors and metal etching compared to CCP [79]. **Fig. 6** shows the
364 schematic of the plasma reactor using RF power with a matching network and using ICP
365 discharge.

366 Literature has also shown the use of RF assisted by magnetron sputtering for plasma
367 doping [80]. Magnetron sputtering increases the rate of ionization followed by plasma density
368 by the introduction of a magnetic field [81]. It is common for the preparation of thin films.
369 Liu, Wen, and Zhao, (2008) synthesized a thin film of N-doped TiO₂ using the radio
370 frequency magnetron sputtering technique, which showed an increase in the composition of
371 N as well as photocatalytic activity as the power of sputtering increased [80].

372

373 **4.2 Microwave-based plasma**

374 For doping photocatalysts, the MPCVD system is commonly used for the generation
375 of plasma of dopant atoms. In the MPCVD reactor, the microwaves of 2.4 GHz generate an
376 electric field which causes the formation of the plasma of the dopant molecules [82]. The
377 microwaves interact with the free electrons remaining in the gas produced by radiation and
378 thermal energy to cause oscillation. These oscillating electrons interact with other atoms and
379 molecules to induce a higher degree of ionization [83,84]. This plasma of the dopant
380 molecules deposits on the photocatalyst to be doped at low pressure. **Fig. 7** shows the plasma
381 reactor using Microwaves for the plasma generation and deposition of dopants in the host
382 photocatalyst.

383 The MPCVD reactor does not require any internal electrodes diminishing the risk of
384 electrode contamination. This allows the production of a thin film of high purity. This process
385 operates at a higher frequency which causes the generation of high-density plasma compared
386 to the RF plasma process. Furthermore, microwave-assisted plasma is preferred due to its
387 greater controllability [80]. Islam et al., (2016) synthesized a mesoporous thin film of TiO₂
388 which was doped using N₂/Ar plasma treatment to evaluate its photocatalytic activity [58]. It
389 was found that the plasma treatment by MPCVD resulted in efficient doping of N atoms by
390 the higher energy of the plasma and disorderliness within the molecules which enhanced the
391 photocurrent compared to the undoped films.

392

393 **4.3 High DC voltage-based plasma**

394 Another way of plasma doping can be performed is by using a high-voltage DC
395 source. Plasma is generated by applying a negative voltage to the cathode which causes the
396 formation of a large electric field in the sheath region. The electrodes also require a cooling
397 system to prevent them from overheating. Subsequently, the photocatalyst is doped using the
398 plasma of dopants [76,85]. Although a high deposition rate can be achieved through this

399 process, it has some limitations [86]. The limitation is its use for the deposition of insulating
400 materials. It causes an accumulation of charge on the insulating material which has a
401 diminishing effect on the plasma. A large portion of the input power is also used to accelerate
402 the ion and generate plasma. Thus, the high voltage applied can cause damage to the thin
403 films or the substrates [66,76]. Despite its limitations, this process for plasma generation is
404 utilized for both liquid and gas-phase plasma because of its simple installation and operation.
405 Gholami et al., (2021) used a plasma reactor shown in **Fig. 8** operated by a high voltage
406 (1200V) DC source for doping of N in WO₃ incorporated mesoporous carbon photocatalyst
407 which caused the reduction of bandgap and enhancement of photocatalytic activity [87].

408

409 **4.4 Dielectric barrier discharge (DBD) plasma**

410 DBD plasma is often used for plasma doping. It is a type of non-thermal plasma
411 generated by applying high AC voltage between electrodes which are isolated by dielectric
412 materials such as quartz, polymer, silica, etc. [88]. The dielectric barrier helps in limiting the
413 discharge current and distributing the plasma in the space between the electrodes. DBD
414 plasma can operate at low temperatures and under atmospheric pressure without requiring a
415 vacuum which makes the process simple and low-cost [89]. In the case of plasma doping,
416 DBD plasma generates electrons with high energy which interact with the precursor or
417 dopant gas to form radicals and excited species which occupy the places within the lattice of
418 photocatalyst as interstitial or substitutional atoms. Plasma doping can be carried out in
419 mainly two ways. One of the ways is where the discharge gas and dopant precursor are
420 different. Another way is where the discharge gas is used as the dopant precursor [67,89].

421 Zhu *et al.*, (2019) used ammonium bicarbonate and boric acid for doping nitrogen and
422 boron in Graphene Oxide (GO). The DBD plasma treatment was performed using H₂ as

423 discharge gas which caused the formation of nitrogen and boron radicals. These radicals
424 introduced structural defects in GO. This doping resulted in enhanced electrical capacitance
425 of the doped GO composites.

426 Chen *et al.*, (2019) doped Nitrogen within the lattice of TiO₂ using DBD cold plasma
427 where the discharge gas was NH₃/Ar. In this case, the discharge gas is used as the dopant
428 precursor. **Fig. 9** shows the experimental setup for N-doping. **Fig. 9(a)** shows the DBD
429 reactor system which contains two copper electrodes between which the plasma is generated.
430 Here, the alumina barrier of 3 mm was used between the electrodes. The high-voltage
431 electrodes are connected to an AC power supply. The doping caused the enhancement of
432 photocatalytic activity with a reduction of the band gap. The substrate is placed on the bottom
433 electrode. On the other hand, **Fig. 9(b)** depicts the plasma doping process where an annealed
434 thin film of TiO₂ is doped using the NH₃/Ar plasma. The flow of NH₃ and Ar are controlled
435 and supplied from their respective cylinder. Before plasma generation, the system is purged
436 with NH₃-removed air to create an inert atmosphere. The flow rates are controlled to vary the
437 concentration of N-doping of TiO₂. Other studies that used DBD plasma treatment include
438 H₂/CCl₄-treated TiO₂ [91], Sulphur doped carbon nitride [92], and O₂-doped MoS₂ [93]. All
439 the photocatalysts doped by DBD plasma have shown enhanced photocatalytic activity.

440

441 **4.5 Liquid Phase Plasma (LPP) Process**

442 In recent years, LPP is widely used for doping nanomaterials which enhances their
443 photocatalytic activity [94]. The advantage of plasma doping using LPP is that it does not
444 require any reducing agent. The doping is performed by the formation of highly active
445 species within the liquid [95–97]. The plasma can be generated in the liquid medium in two
446 ways [98]. The first method is the streamer discharge where plasma is discharged in small
447 channels, as shown in **Fig. 10(b)**. In this streamer discharge method, the density of liquid

448 near the electrode is reduced, causing the formation of cavitation bubbles by the high
449 overvoltage electric field or the collision of electrons with the liquid [99]. Another LPP
450 method is the plasma in bubbles. In this method, the plasma is formed inside the bubbles as
451 shown in **Fig. 10(a)**. Under high voltage, bubbles are formed by the evaporation of water
452 caused by joule heating. When a required threshold voltage is applied, plasma is formed
453 within the bubbles which coalesce under the electric field to create a continuous channel of
454 plasma between the electrodes [100]. The analysis of the plasma produced in liquid shows
455 the formation of OH radicals, atomic H, and atomic O. This proves the plasma is formed due
456 to the excitation of water molecules in the bubble rather than air. Sometimes the analysis
457 shows the presence of atomic N due to the dissolution of air [98,99,101]. The drawback of
458 LPP is the melting of the electrodes and contamination of the products as the electrodes are
459 immersed within the solution. To address this challenge, the choice of electrode material is
460 significant. For ultrasonic homogenizer coupled with the microwave antenna electrode can be
461 used for the efficient generation of plasma within the bubbles and to reduce the surface
462 deterioration of the electrode materials [99,102].

463 The plasma can be generated depending on the electrode arrangement using AC
464 power, high DC voltage, Microwave or RF, and laser ablation technique. Jung et al., (2022)
465 used the LPP process using a high-voltage power supply to generate plasma, and pulsed
466 plasma discharge was used to prevent the deterioration of the electrodes [103]. The
467 $\text{Eu}(\text{NO}_3)_3 \cdot 5\text{H}_2\text{O}$ precursor solution was used for plasma doping of Europium oxide on TiO_2
468 which showed enhanced photocatalytic activity. Sang-Chul Jung and his coworkers reported
469 enhanced photocatalytic activity by plasma doping using LPP using the setup mentioned
470 above. They have synthesized WO_3 -doped TiO_2 [104], Fe-N-doped TiO_2 [94], Iron oxide-
471 doped TiO_2 [105], and Eu and N co-doped TiO_2 [106]. These doped photocatalysts showed
472 enhanced photocatalytic activity. The enhanced photocatalytic activity was evident as there

473 was a reduction of band gap by values up to 0.25 eV. Also, it was evident through the
474 enhanced degradation of pollutants. The enhanced photocatalytic activity was evident by the
475 reduction of band gap up to 0.25 eV and it was evident through enhanced degradation of
476 pollutants such as Acid Orange, Methylene Blue, Diethyl Phthalate, and Diclofenac. **Table 2**
477 depicts each type of plasma with its benefits, limitations, and scopes of application [9, 66, 98,
478 99, 128-131].

479

480 **5. Plasma-doped photocatalyst**

481 In recent times, nano photocatalysts are being used for various purposes in different
482 environments. The photocatalytic activity and usability can be significantly improved by the
483 doping process, as doping provides improved surface properties, reduction of bandgap
484 energy, and restricts the recombination of electron-hole pairs. Previously the advantages of
485 plasma doping over other methods have been thoroughly discussed. In plasma doping,
486 metals, non-metals molecules, and atoms, different types of gases are incorporated with
487 varieties of nano-catalysts using different methodologies. Several researchers reported
488 different plasma treatment methodologies on the photo-catalyst to obtain smaller particle size,
489 wider light absorption range, reduced bandgap energy, and improved charge separation
490 efficiency with enhanced photocatalytic activity. The plasma has been applied to treat a wide
491 range of photocatalysts with various dopants. The photocatalysts include TiO₂, Cu₂O/CuO,
492 CdS, and ZnO. The dopants include non-metals e.g., nitrogen, and hydrogen, and metals e.g.,
493 iron (Fe), silver (Ag), copper (Cu), and europium (Eu). The doped photocatalysts have been
494 used for diverse applications including dyes and organic pollutants degradation, and
495 photoelectrochemical water splitting-based hydrogen production under visible light of solar
496 energy.

497 Plasma-doped photocatalysts have been utilized to degrade organic dye from an
498 aqueous solution. In plasma-treated photocatalysts, nitrogen distribution is more uniform
499 throughout the depth of the film than in the conventional doped catalyst, which increases the
500 catalytic characteristics and degradation performances. Hyun Uk Lee et al. (2014) reported
501 the photocatalytic characteristics of plasma-treated nitrogen-doped nanoporous TiO₂ (N-
502 TiO₂) for the degradation of Rhodamine B dye [107]. The radio frequency generator used
503 argon (Ar) as carrier gas and N₂ as reactive gas to synthesize the N-TiO₂. The synthesized N-
504 TiO₂ showed increased surface area (375.9 m² g⁻¹) compared to commercial anatase TiO₂.
505 The band gap was reduced and high photostability was obtained with N-TiO₂. Moreover, N-
506 TiO₂ exhibited an accelerated transformation from anatase to rutile phase at low annealing
507 temperature with increased photocurrent density. Islam et. al. (2016) reported the N-doped
508 mesoporous TiO₂ thin film synthesis and its photocatalytic activity [58]. The sample was
509 purged with Ar at 100 standard cubic centimeters per minute (sccm) in the MPCVD system at
510 an N₂ flow rate of 40 sccm. The synthesized N-doped TiO₂ showed uniform N₂ distribution
511 through the depth of the film and a reduced bandgap energy of 2.88 eV. The dye degradation
512 rate coefficient and photocurrents increased by 6 times and 80-240 times, respectively.
513 Wenxia Zhao et al. (2019) reported the preparation and photocatalytic activity of plasma-
514 treated N-TiO₂ for the degradation of methyl orange dye [65]. The non-thermal plasma (cold
515 plasma) process was followed to avoid surface reduction and defects due to the sintering of
516 the photocatalyst. The conventional N-TiO₂ prepared by the sol-gel method was treated in a
517 DBD reactor for 30 min at 15 W with an N₂ flow rate of 450 mL/min. The plasma-treated N-
518 TiO₂ showed a reduced bandgap energy of 1.7 eV compared to the conventional N-TiO₂ (~3.0
519 eV). The reaction rate was ~2.8 times higher and about 35 % greater MO degradation was
520 achieved in plasma-treated N-TiO₂. P. Manojkumar et. al. (2020) utilized plasma electrolytic
521 oxidation (PEO) on transitional metal-doped (Mo/V/W) TiO₂ for the mineralization of MB

522 dye [108]. In an immobilized photocatalytic surface, doping materials (Mo/V/W) were added
523 to commercial pure TiO₂ and treated with PEO for 8 min with 150 mA/cm² current density,
524 which subsequently restricted the formation of rutile phase in TiO₂ and increases the surface
525 area. Higher charge separation efficiency, low recombination rate, and increased
526 mineralization of MB dye were obtained with plasma-doped TiO₂. Moreover, plasma-treated
527 photocatalysts have been reported to be successfully used in different areas. Cheng-Yen Tsai
528 et al. (2013) reported the gaseous low-concentration mercury (Hg) removal by Cu-doped
529 TiO₂ treated with atmospheric pressure thermal Ar/O₂ plasma with a DC non-transferred
530 plasma torch [109]. Peimei Dong et. al. (2019) reported the green synthesis of N-TiO₂ nano-
531 photocatalyst by H₂ cold plasma treated Ag deposition [64]. The sample was placed in a DBD
532 reactor where Ar-H₂ is pumped at 50 L/min for 5min. Recently, some researchers have
533 reported the utilization of the liquid phase plasma process (LPP). Seo Jin Ki et. al. (2019)
534 reported the facile synthesis of tungsten oxide doped TiO₂ photocatalyst by LPP and utilized
535 it to degrade diethyl phthalate [104]. The LPP-treated TiO₂ exhibited specific surface area
536 reduction (by blocking mesopores) and enlarged pore diameter, which improved the
537 photocatalytic activity. The synthesized photocatalyst gave 1.7 to 6.2 times more
538 degradation of under blue light diethyl phthalate compared to TiO₂. In another study, Sang-
539 Chul Jung et. al. (2022) assessed the photocatalytic activity of LPP-treated europium (Eu)
540 doped TiO₂ (Eu-TiO₂) for the mineralization of acetylsalicylic acid [106]. For the preparation
541 of the photocatalyst, powder TiO₂, and Eu precursor was dispersed in a cylindrical quart
542 batch reactor and direct pulse type plasma was used to prevent corrosion of electrodes. In the
543 LPP-treated photocatalyst, Eu was uniformly precipitated on the TiO₂ surface from the
544 precursor and atomic oxygen % increased significantly, which showed enhanced
545 photocatalytic activity to degrade acetylsalicylic acid. Semiconductors other than TiO₂ have
546 also been used doped using plasma-based methods for different applications. In another

547 study, Lixiang Zhang et. al. (2021) used plasma-assisted nitrogen doping to form CdS/N-
548 CoS_x (cadmium sulfide/N-doped cobalt sulfide) for photocatalytic Cr (VI) reduction. The
549 plasma doping introduced enhanced surface wettability and conductivity. The facilitated Co-
550 N bonds showed the best photocatalytic activity for 5 min of plasma treatment [110]. **Table 3**
551 summarizes different plasma-doped photocatalysts and their environmental applications [58,
552 64, 65, 103, 107-110, 132, 133].

553 The plasma-treated photocatalyst has also been utilized in photochemical water oxidation.
554 The photoelectrochemical water splitting activity was evaluated with the plasma-treated
555 (MPCVD system) nitrogen and hydrogen-doped mesoporous TiO₂ thin film [44,111].
556 Efficient separation of electron-hole pair separation, facile interfacial charge transfer, and
557 high surface area were obtained by plasma-treated TiO₂, which significantly enhanced the
558 water oxidation. Liu et al. (2021) assessed the photocatalytic activity of N-plasma-doped
559 TiO₂ nanosheets. It was found that plasma-doped TiO₂ resulted in H₂ evolution 14.85 times
560 greater than that of undoped TiO₂. The enhancement of photoactivity was due to oxygen
561 vacancies and the reduction of Ti⁴⁺ to Ti³⁺ [112]. Yan et al. (2019) synthesized C-doped
562 Co₃O₄ by CH₄ plasma and utilized the photocatalyst for water splitting. Plasma-assisted-sted
563 incorporation of the C atom resulted in oxygen vacancies and substitution defects forming the
564 Co-C bond. The Co-C bond and vacancies enhanced Hydrogen Evolution Reaction (HER)
565 and Oxygen Evolution reaction (OER), respectively. In another study, Gholami et al. (2021)
566 utilized a Magnetic WO_{3-x}-@Mesoporous carbon photocatalyst doped using N₂ plasma for
567 enhanced H₂ production and antibiotic degradation. The H₂ evolution was found to be twice
568 that of an undoped photocatalyst [87]. In a recent study, Wenwen Zhang et. al. (2020)
569 reported the construction of an N-Cu₂O/CuO photocatalyst by N₂ plasma treating of Cu₂O
570 octahedrons for H₂O₂ production under visible light [45]. The Cu₂O octahedron was placed
571 in a plasma chamber (RF 13.56 MHz, 45 W) with an N₂ flow rate of 50 sccm and 100Pa. The

572 synthesized photocatalyst boosted the charge separation and transfer of photocurrent. The
573 photocatalytic performance was dependent on plasma treatment time. The H₂O₂ generation of
574 approximately 14 μMg⁻¹min⁻¹ was achieved at 10 min of plasma treatment, which is 3 and 8
575 times more than Cu₂O and CuO, respectively. In one of the studies, Bello Ladan Muhammad
576 et. al. (2021) investigated the optical properties of plasma-irradiated Fe-doped ZnO (Fe: ZnO)
577 nanowires [113]. A CVD chamber was used with plasma power 500 W for 10 min. The
578 plasma treatment increased the photoconductivity of the Fe: ZnO nanowires and the presence
579 of a high density of shallow donor states were identified. **Table 4** summarizes different
580 plasma-doped photocatalysts utilized for energy and other applications [44, 45, 71, 87, 111-
581 113].

582 These studies suggest that the plasma-based process is a versatile technique for doping a
583 wide range of photocatalysts with enhanced photocatalytic activities for environmental and
584 energy applications. The versatile plasma approach can be further applied to many other
585 photocatalysts including SnO₂. To reveal the diverse applications of plasma-treated
586 photocatalysts, continuous research is going on, which would unveil more interesting
587 characteristics of the plasma-treated catalysts in the near future.

588

589 **6. Conclusions and Future perspectives**

590 Plasma-based doping of semiconductor photocatalysts was shown remarkable
591 performances in band gap engineering and enhanced visible light absorption which was the
592 major part of solar energy. Among various doping methods, plasma treatment offered
593 significant advantages including high doping efficiency by producing highly reactive
594 radicals, atoms, and species, process simplicity, ability to reduce band gap to a large extent,
595 relatively low-temperature operation, maintaining nanostructure of the original

596 nanomaterials, ability to dope a wide range of photocatalysts and capability of operating in
597 both gas and liquid phases. The plasma-treated photocatalysts showed significantly higher
598 photocatalytic performance than the materials doped by other methods. Although significant
599 advances were made, there are still some knowledge gaps on various aspects of the plasma
600 doping process. More theoretical studies were needed to understand the mechanism of plasma
601 doping processes, the interaction of the plasma species with the materials, and the impact of
602 various process parameters using high-performance computational modeling and simulations.
603 Correlations between theoretical and experimental results were also needed to advance the
604 plasma doping process.

605 The photocatalytic activities of most of the photocatalysts developed by plasma
606 treatment were evaluated mostly by dye degradation such as methylene blue. However,
607 limited studies were performed on the real-life applications of those photocatalysts. Extensive
608 studies were essential to determine the potential applications of those photocatalysts in
609 environmental and energy industries. For example, photocatalysts could be applied to energy-
610 efficient wastewater treatment with emerging pollutants such as degradation of Microcystin-
611 LR and Perfluoroalkyl and Polyfluoroalkyl Substances (PFAS) using solar energy. Those
612 photocatalysts could be incorporated into porous membranes to develop continuous
613 photocatalytic membrane reactors as opposed to the currently practiced batch reactor for
614 wastewater treatment and environmental remediation.

615 These highly efficient photocatalysts also disclosed tremendous promise in harnessing
616 and conversion of solar energy into solar fuel. For example, clean and green hydrogen was
617 produced by water splitting using the visible light active plasma treated photocatalysts driven
618 by solar energy. The plasma-treated photocatalysts also played a critical role in industrial
619 decarbonization and mitigating global warming. The photocatalysts absorbed sunlight and

620 used it for solar fuel production by combining carbon dioxide and water into fuel such as
621 methanol, ethanol, or formic acid.

622 Another non-traditional application of those photocatalysts could be solar
623 desalination. The demand for clean water was grown rapidly due to population growth,
624 enhanced energy usage, and climate change. According to a World Bank report published in
625 2019, nearly half of the World's population experienced water scarcity every year. This dire
626 water crisis in many water-scarce areas could be mitigated by producing clean water from
627 inland and local brackish water sources due to its low salinity and widespread availability.
628 Utilization of carbon-neutral renewable energy such as solar energy could be a novel
629 approach for energy-efficient and potentially cost-effective desalination. Solar energy could
630 be harnessed by plasma-treated photocatalysts for desalination by photo-electrodialysis
631 process. In the photo-electrodialysis cell, a photoanode/photocatalyst absorbed the sunlight
632 and produces electrons and holes. The excited holes oxidized water to produce oxygen gas
633 and hydrogen ions. On the other hand, the excited electrons moved from the anode to the
634 cathode, and reduce water to produce hydrogen gas and hydroxide ion which combined with
635 the sodium ion of saline water to produce sodium hydroxide. Overall, clean water was
636 produced from the saline water with the generation of hydrogen gas and sodium hydroxide.

637 Comprehensive research and development were critical for the development of
638 energy-efficient, cost-effective, and scalable processes for industrial implementation of those
639 advanced solar materials. Finally, techno-economic analysis and life cycle assessment were
640 essential to evaluate the commercial viability and environmental sustainability of those
641 promising solar materials.

642 For in-depth understanding, modeling is an efficient approach to simulate the plasma
643 doping process. However, most of the studies in this field deal with plasma fluid modeling
644 and there was very limited research reporting the in-situ modeling of a plasma doping process

645 and its correlation with the photocatalytic characteristics. The interactions of
646 radicals/atoms/particles with metal oxide photocatalysts have not received attention yet [114].
647 The molecular dynamics simulation (MD) approach for understanding the doping process and
648 its impact on the photocatalytic nature should be studied to obtain an in-depth knowledge of
649 the plasma doping process.

650

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655

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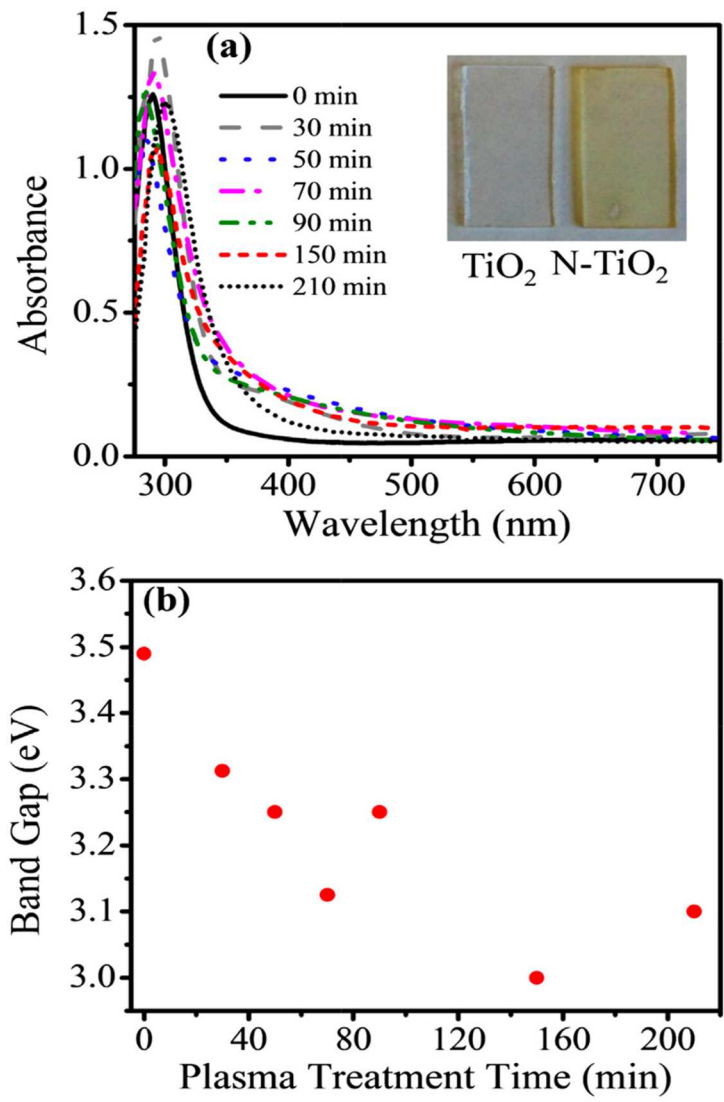


Fig. 1: (a) UV-vis spectra of undoped TiO₂ and plasma-treated nitrogen-doped TiO₂ (N-TiO₂) films with a variation of plasma treatment time and (b) variation of band gap with the time of plasma treatment [58].

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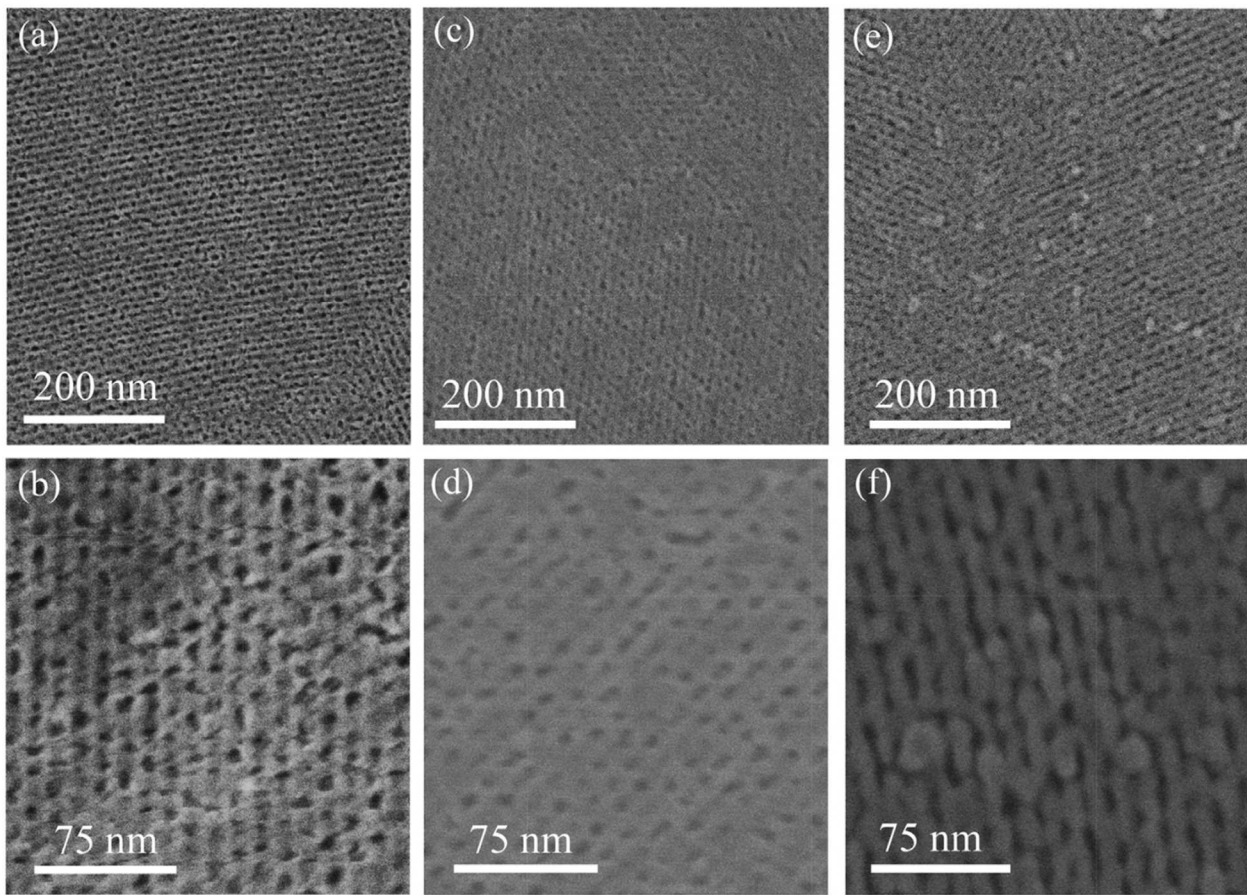


Fig. 2: SEM images of (a, b) undoped TiO₂ (c, d) 30 min plasma treated nitrogen-doped TiO₂ and (e, f) 210 min plasma treated nitrogen-doped TiO₂ films [58].

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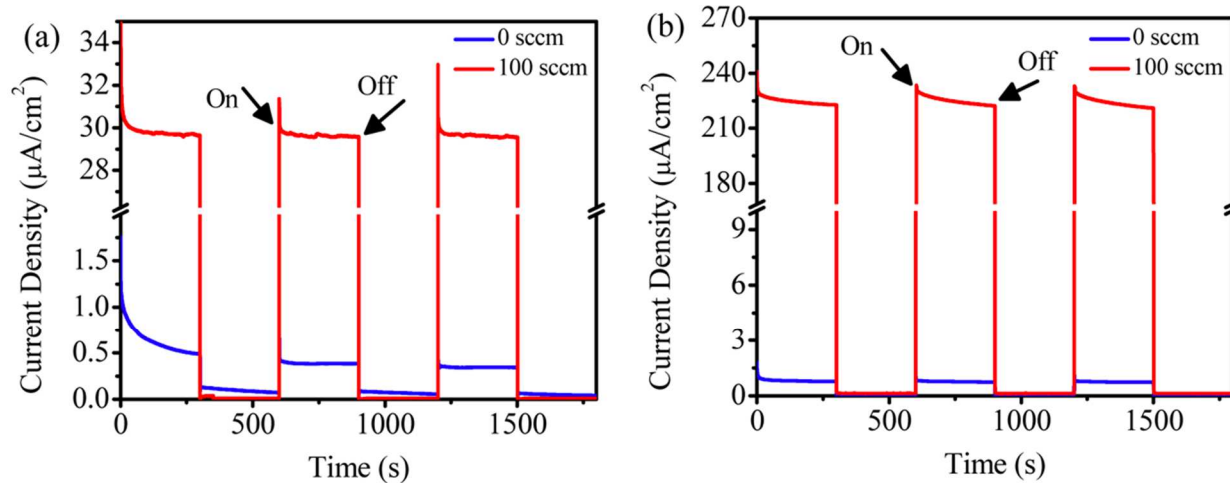
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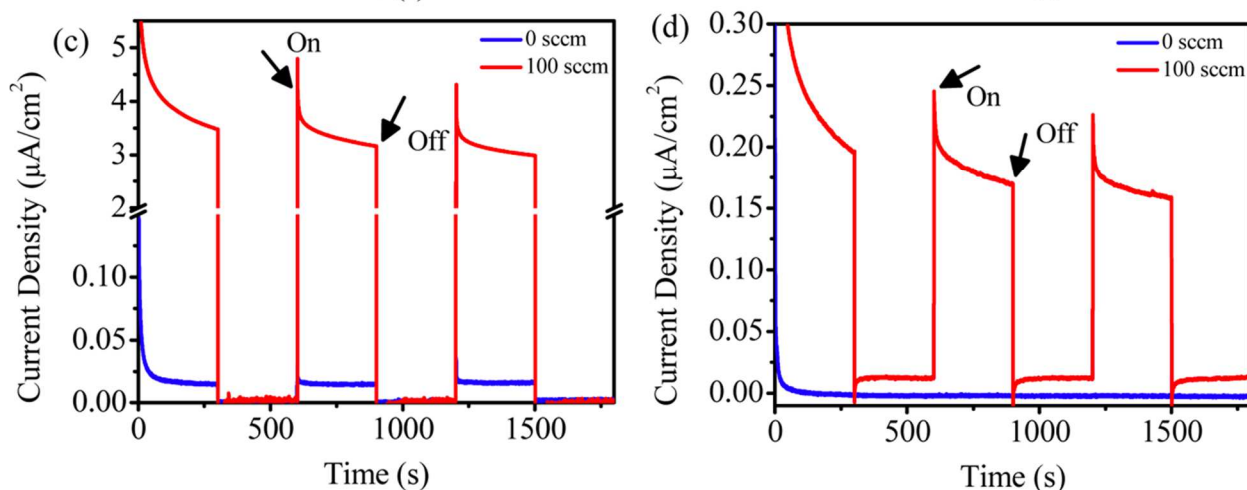
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1131 **Fig. 3:** Current density (micro A/cm²) vs. time (s) profiles with 0 standard cubic centimeters
1132 per minute (sccm) nitrogen-doped TiO₂ (untreated) and 100 standard cubic centimeters per
1133 minute nitrogen-doped TiO₂ films under the illumination of (a) Xe arc lamp with AM 1.5 G
1134 filter, (b) UV-LED (UVLED), (c) blue-LED (BLED), and (d) green-LED (GLED) [44].

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1150 **Fig. 4:** The steps included in the plasma doping process in the PECVD reactors [66,115].

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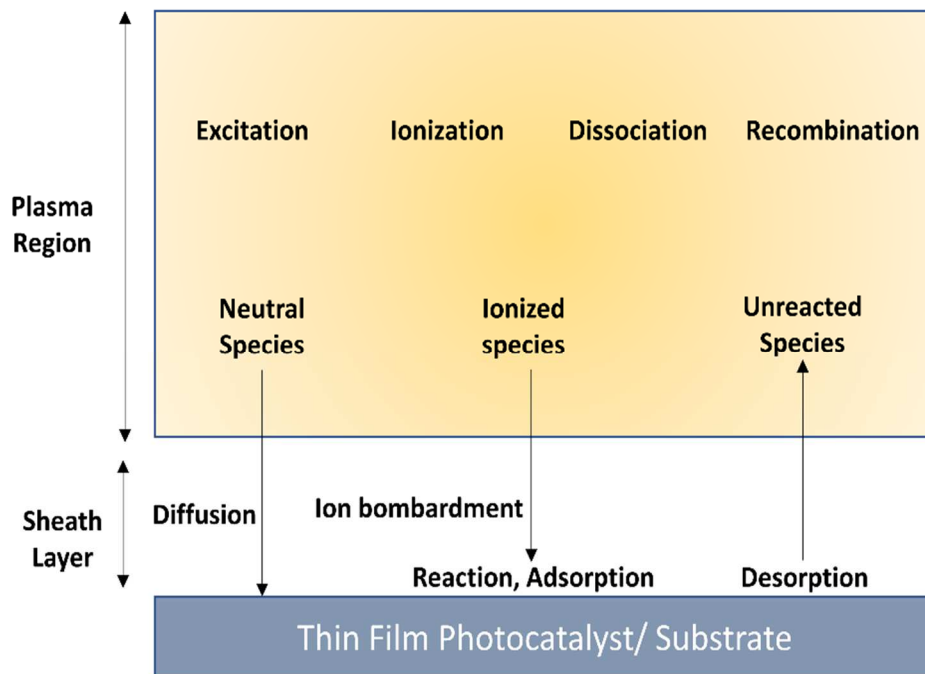
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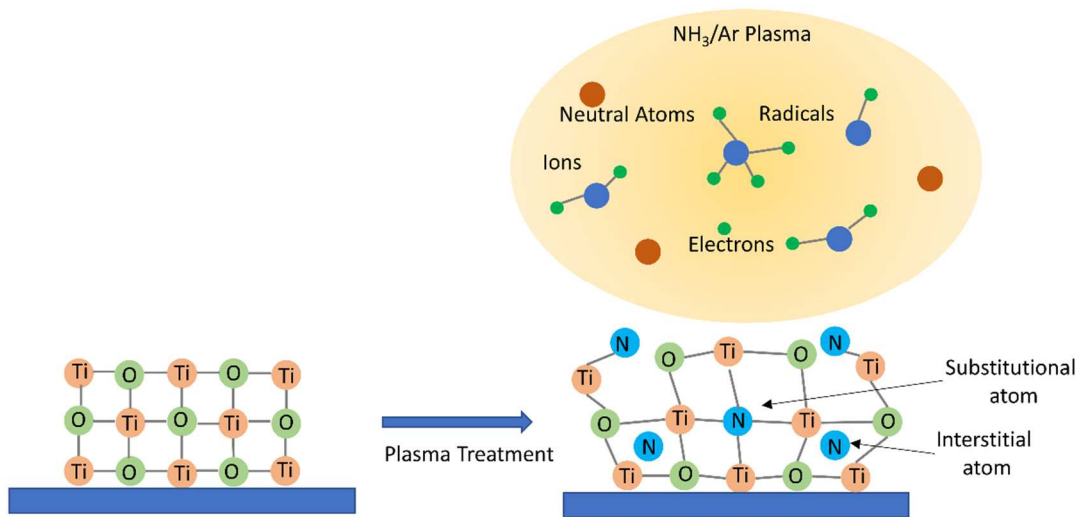


Fig. 5: Mechanism of Nitrogen doping of TiO₂ using NH₃/Ar plasma [67].

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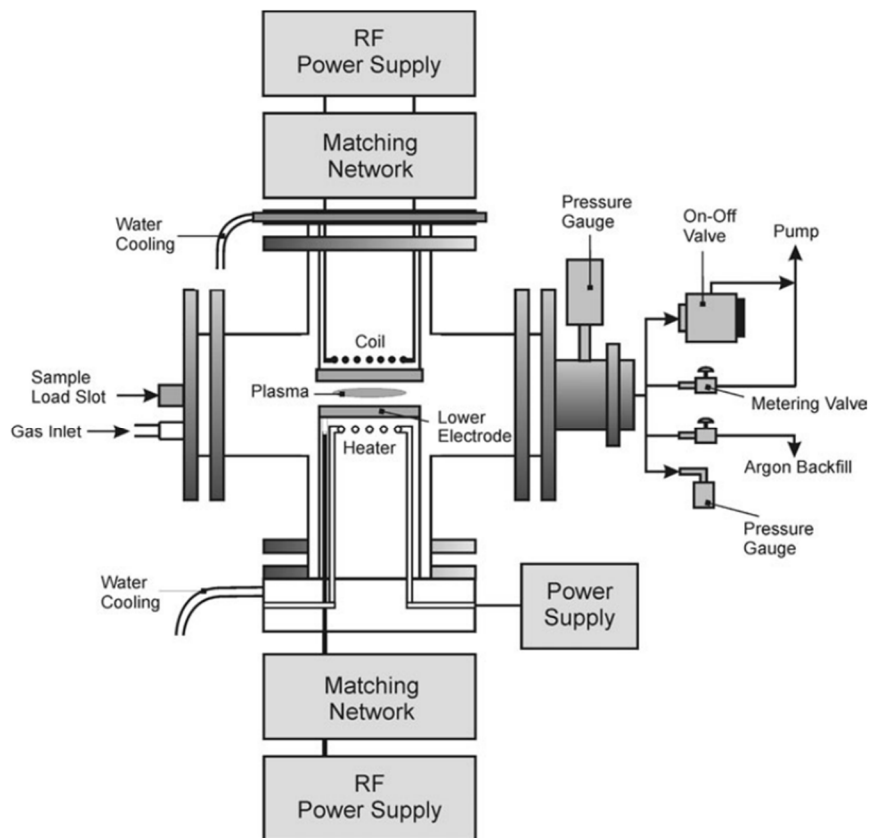
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1195 **Fig. 6:** Schematic of RFCVD plasma reactor with ICP [70].

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1213 **Fig. 7:** Schematic of MPCVD reactor [58,111].

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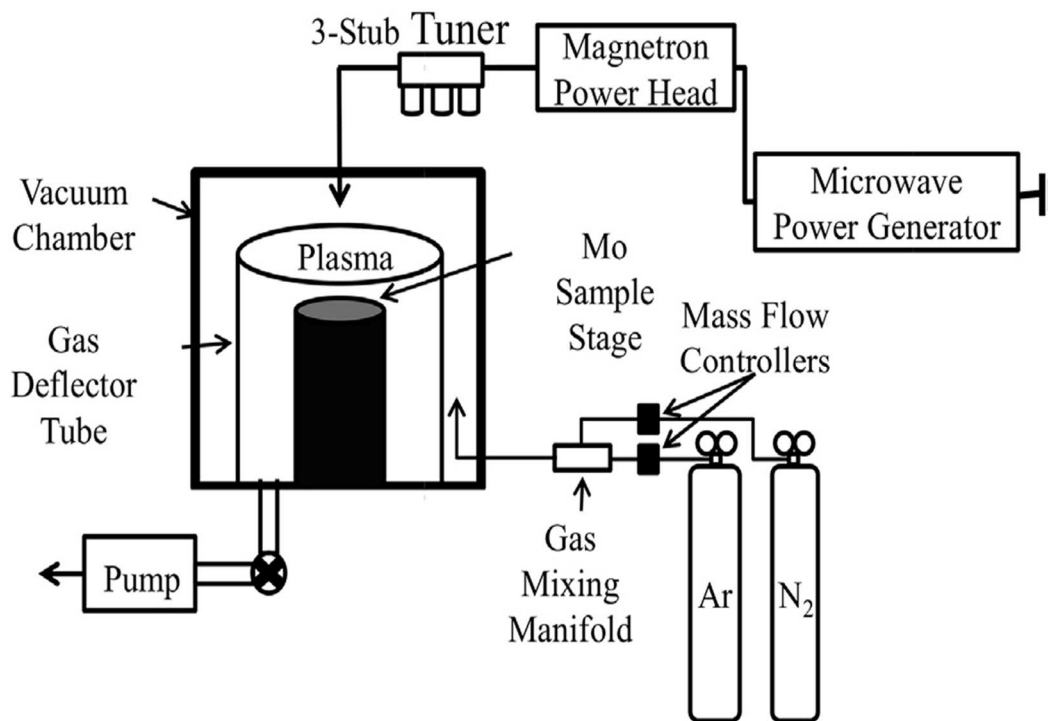
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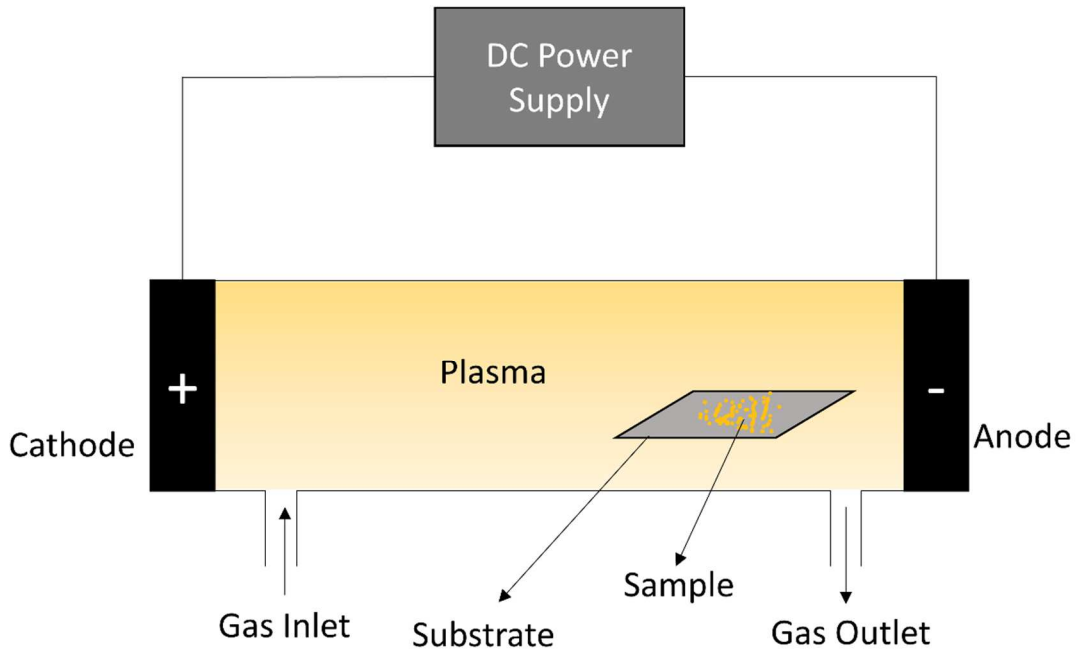


Fig. 8: Schematic of DC plasma reactor [87].

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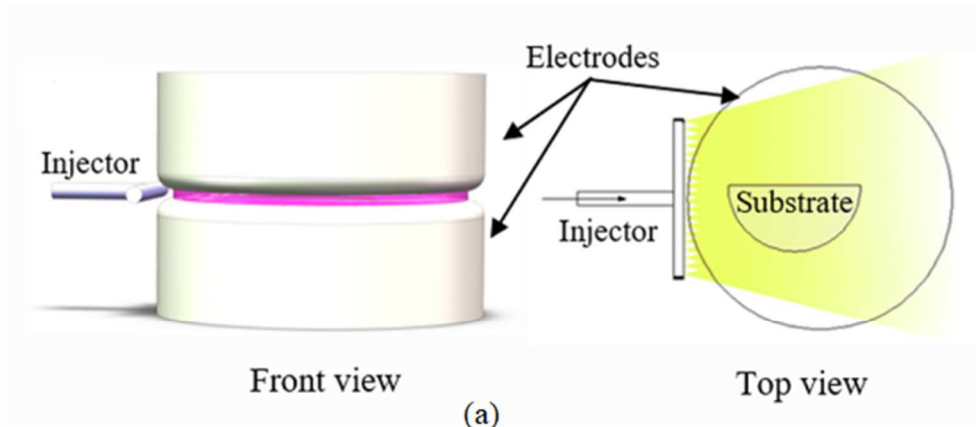
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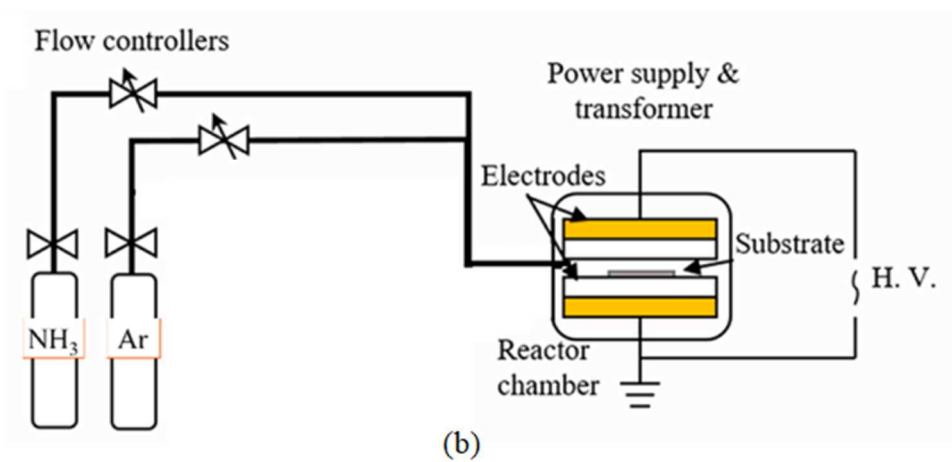
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1254 **Fig. 9:** Schematic of (a) DBD plasma discharge for doping, (b) experimental setup for DBD
1255 plasma doping [67].

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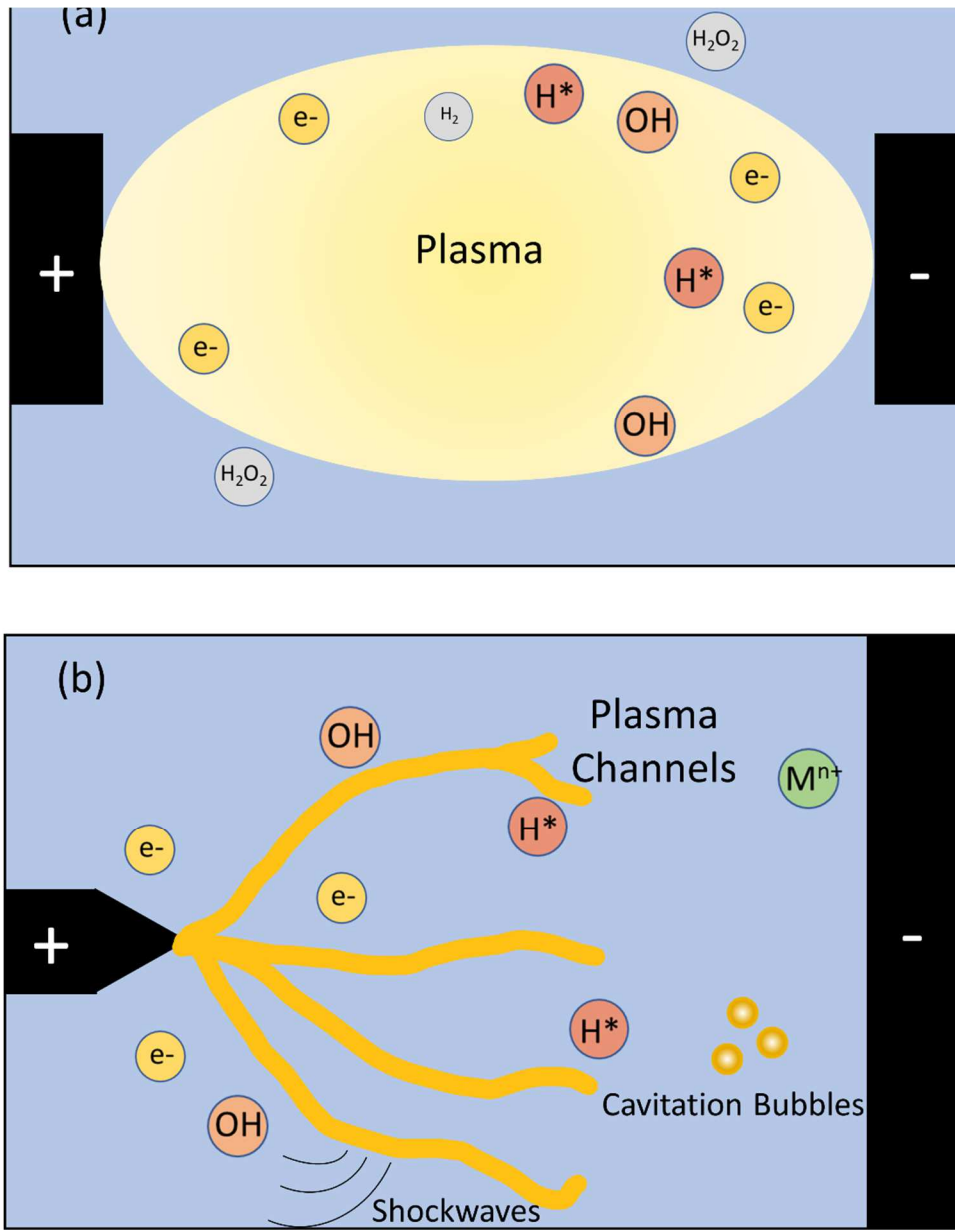


Fig. 10: LPP process for plasma generation for (a) plasma in a bubble, and (b) streamer plasma discharge [99].

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1284 **Table 1:** Descriptive analysis of several doping techniques.

Method	Description	Advantages	Disadvantages	Reference
Sol-gel	A wet chemical process involving hydrolysis and condensation reaction of precursors such as metal alkoxides and chlorides, with water or alcohol.	<ul style="list-style-type: none"> - practical, adaptable, easily controllable, no vacuum - can be assisted by other methods - low cost and simple operating requirements - homogenous and reproducible - yields high purity and desired stoichiometry 	<ul style="list-style-type: none"> - time consuming - fracture on thin films - a long period of deposition - requires high chemicals - may pose challenges while incorporating a dopant precursor into a certain type of photocatalyst without damaging its structure 	[116–119]

Method	Description	Advantages	Disadvantages	Reference
CVD	A thin film of metal oxide is formed by the materials and precursor condensation from a vapor phase to form a solid state.	<ul style="list-style-type: none"> - Excellent adhesively - generate uniformly distributed films - high density obtained along with controlled crystal structure and uniform films - increased corrosion and wear resistance 	<ul style="list-style-type: none"> - high operating and capital cost - high reaction temperature - slow process - vacuum needed - nanostructure easily damaged due to high temperature 	[116,120,121]
PVD	It involves physical processes such as evaporation, the collision of ions or sublimation, and the transfer of atoms from a solid or molten state to a surface.	<ul style="list-style-type: none"> - suitable for any type of inorganic materials - thermal evaporation process is protected from defect nucleation and damage although sputtering is not - enhanced hardness and 	<ul style="list-style-type: none"> - high vacuum and temperature - slow and costly - additional cost of cooling system - impurity layer deposition - multiple steps required - high energy due to resistive heating 	[116]

Method	Description	Advantages	Disadvantages	Reference
		resistance to oxidation and wear - environmentally approachable	and electrons beam - the high surface area of some photocatalysts may not be maintained due to high temperature - may pose challenges while incorporating a dopant precursor into a certain type of photocatalyst without damaging its structure	
Spray pyrolysis	An ionic solution containing the doping materials in the form of soluble salts is sprayed using a nanoporous uniformly distributed nebulizer onto the heated substrate in the furnace.	- can be operated at atmospheric pressure, maintain stoichiometry and homogeneity - multilayer fabrication capability - different precursors can be used - cheap and can be easily performed	- high flowrate can cause the heterogeneous coating - heating required for thermal treatment - may pose challenges while incorporating a dopant precursor into a certain type of photocatalyst without damaging its structure	[122,123]

Method	Description	Advantages	Disadvantages	Reference
Hydrothermal	This is a wet chemical process under mild reaction conditions by controlling reaction parameters such as temperature, pressure, pH, time, and surfactant.	<ul style="list-style-type: none"> - low energy requirement - simple equipment - controllable morphology - high-phase purity - size selective growth with small particle size 	<ul style="list-style-type: none"> - costly autoclave required - at higher temperatures, clustering can happen - may pose challenges while incorporating a dopant precursor into a certain type of photocatalyst without damaging its structure 	[124,125]

Method	Description	Advantages	Disadvantages	Reference
Plasma treatment	Fragmenting dopant precursor molecules using active plasma that deposit onto the photocatalyst surface	<ul style="list-style-type: none"> - no need for organic solvents and green technology - avoids catalyst poisoning - chemical, thermal, and mechanical stabilities - single step and less costly - pore-free and uniform films - low chemical consumption - dry process - less water and energy consumption 	- relatively equipment cost	[58,126,127]

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1287 **Table 2:** Advantages and disadvantages of various types of plasma.

Plasma Types	Advantages	Disadvantages	Application	Reference
PECVD (Plasma-Enhanced Chemical Vapor Deposition)	<ul style="list-style-type: none"> -Simple reactor -Vapor molecules break very easily - Facilitates the growth of films at a low-temperature substrate temperature -Reasonable deposition rate on films -The uniform surface of films -Highly pure 	<ul style="list-style-type: none"> -Difficult to control the stoichiometry -Probable surface damage by ion bombardment -The possibility of contamination of particle and chemical - Relatively expensive -The system becomes complex as a pumping system is required for maintaining low pressure 	<ul style="list-style-type: none"> -Microelectronics development -Fabrication of integrated circuits, solar cells, transistors, photovoltaic and photonic applications -Development of organic polymers and organometallic compounds -Biological applications such as immobilization of biomolecules, surface treatments of implants, and biomaterials 	[66,128]
MPD (Microwave Plasma Discharge)	<ul style="list-style-type: none"> -High energy density and high ionization rate -Efficient use of input energy -Operation pressure can vary from millitorr to atmospheric pressure 	<ul style="list-style-type: none"> -Can be complex and expensive to incorporate high-frequency power 	-Syngas production system	[129]
RFPD (Radio Frequency Plasma)	-No direct contact between plasma and electrode is needed	-	-Syngas production system	[129]

Discharge)				
DBD (Dielectric Barrier Discharge)	<ul style="list-style-type: none"> -Green & Efficient -No release of hazardous chemicals -Comparatively easier construction -Simple and easy operation -Fast and facile method -Improves property and enhances catalytic performance -Enhance distribution of metal nanoparticles 	<ul style="list-style-type: none"> -Nonuniform, filamentary structure -Limited current, low temperature of the gas -Low power density -Additional energy requirement to preheat the reactant 	<ul style="list-style-type: none"> -Quick and easy preparation of supported metal catalysts for energy and environmental application. -Mesoporous photocatalyst with enhanced activity -Automobile exhaust gas catalysis -CO₂ reforming of CH₄ -CO and CO₂ methanation -CH₄ conversion -Methanol photooxidation 	[130,131]
LPP (Liquid Phase Plasma)	<ul style="list-style-type: none"> -Automatic production of reducing agents -No external addition of toxic chemical reducing and stabilizing agent so comparatively pure -Environment friendly -One-step, fast, and wide-scale synthesis process of nanomaterial -The presence of a novel plasma liquid interface -Physical and chemical parameters can 	<ul style="list-style-type: none"> -Detailed spatial and temporal evolutions of the processes are not well understood 	<ul style="list-style-type: none"> -Fabrication of different nanomaterials of various characteristics 	[98,99]

	<ul style="list-style-type: none"> be controlled easily -Nanomaterial nucleation and growth can be controlled -Composition, size, and shape of nanomaterial can be finely tuned -No gas, pumping system, or water-cooled vacuum chamber is needed, so less costly 			
Arc Discharge	<ul style="list-style-type: none"> -Insensitive to changes in environment and pressure -Simple operation -Can provide the high temperature needed for gasification -High production rate -High-quality product -Comparatively less impure product 	<ul style="list-style-type: none"> -High electric energy requirement, so costly -Expensive equipment 	-Fuel conversion	[9,129]
Ion Implantation	<ul style="list-style-type: none"> -Doping dosage and depth can be controlled -Uniform surface -A wide range of operating temperature -Less impurity 	<ul style="list-style-type: none"> -More expensive equipment -A high requirement for energy input -Non-uniform 		[9]
Corona Discharge	<ul style="list-style-type: none"> - Efficient power transfer into the plasma discharge -Satisfactory spatial uniformity 		-Catalytic effect in combustion and fuel conversion	[129]

1289 **Table 3:** Photocatalysts doped with various dopants using plasma treatments for environmental applications.

Types of Plasma	Photocatalyst	Plasma treatment method	Scope	Effects of plasma	Reference
N ₂ non-thermal plasma/cold plasma	N-TiO ₂	N-TiO ₂ treated in DBD reactor for 30min at 15W, N ₂ flow rate 450mL/min	Methyl orange degradation	-Bandgap was reduced to 1.7 from 3.0 eV for bare TiO ₂ -higher substitutional N and surface O ₂ -2.8 times higher reaction rate and -13-35% higher degradation rate compared to conventional N-TiO ₂ (without plasma treatment)	[65]
	Nanoporous TiO ₂	RF generator used with Ar as carrier gas and N ₂ as reactive gas	-Organic dye degradation -Medical application as an antibacterial	- Increment of surface energy -Reduction of band gap energy to below	[107]

			agent	3.2 eV -High photostability and durability	
	TiO ₂ nanotube arrays	A quartz tube of 2.2cm inner diameter acted as a reactor at 200 Pa pressure		-Better photocatalytic activity -A facile transformation from anatase to rutile phase at the low annealing temperature -Greater photocurrent density	[132]
N ₂ /Ar plasma	TiO ₂	MPCVD system purged with Ar at 100 sccm and N ₂ at 40 sccm	-Degradation of methylene blue dye under visible light -Water oxidation activity enhancement	- 18% reduction of specific surface area -Uniform N ₂ distribution through the depth of the film -Dye degradation rate coefficient increased by 6 times	[58]

Ar/O ₂ plasma	Cu-TiO ₂	Atmospheric pressure thermal plasma with a DC non-transferred plasma torch	Preparation and doping of nano-catalyst for gaseous elemental Hg removal	<ul style="list-style-type: none"> -single step surface modification -clean nanoparticle surface -Cu species highly distributed in TiO₂ -enhanced conductivity and electron trapping 	[109]
H ₂ cold plasma	Ag/N-TiO ₂ nanotube	The sample was placed in a DBD reactor where Ar-H ₂ is pumped at 50 L/min for 5 min	Green and efficient synthesis of photocatalyst	<ul style="list-style-type: none"> -Ag nanoparticles evenly distributed on the inner walls of nanotubes -small particle size of 5.8nm 	[64]

Eu (Liquid Phase Plasma)	TiO ₂	Powder TiO ₂ and Eu precursor dispersed in a cylindrical quartz batch reactor and direct pulse type plasma used to prevent corrosion of electrodes	<ul style="list-style-type: none"> -Mineralization of acetylsalicylic acid -Decomposition of environmental pollutants 	<ul style="list-style-type: none"> -Eu uniformly precipitated on the TiO₂ surface from the precursor -A shift of the Raman peak to a higher wavelength -Higher photocatalytic efficiency -Atomic oxygen % increased -Bandgap energy reduction from 3.18 to 3.03 eV 	[103]
Tungsten oxide (Liquid Phase Plasma)	TiO ₂	Tungsten hexachloride was added to the solution of ethanol and deionized water and 0.5g TiO ₂ was added later	Degradation of diethyl phthalate	<ul style="list-style-type: none"> -Specific surface area reduction by blocking mesopores -Enlarged pore diameter -Improvement of photocatalytic 	[109]

				<p>activity</p> <ul style="list-style-type: none"> -Reduction of intrinsic bandgap energy -1.7 to 6.2 times more degradation under blue light 	
Mo/V/W	Commercially pure TiO ₂	In an immobilized photocatalytic surface doping materials were added to TiO ₂ , PEO (Plasma electrolytic oxidation) treated for 8 min with 150 mA/cm ² current density	Can be repeatedly used for textile wastewater treatment	<ul style="list-style-type: none"> -Suppressed the formation of rutile -Higher number of pores on the surface and active surface area -High charge separation efficiency, low recombination rate -Increased mineralization of MB dye 	[108]

N ₂ plasma	CdS/N-CoS _x	CoS _x polyhedrons were placed in a plasma chamber (RF 13.56 MHz. 45W) and N ₂ flow at 100 Pa, followed by the solvothermal method	Cr(VI) reduction	-Enhanced surface wettability and conductivity -Facilitates Co-N bond -5 min plasma treatment shows the best photocatalytic activity	[110]
H ₂ S plasma	S-doped g-C ₃ N ₄	DBD reactor was operated at a constant flow of H ₂ S (40 mL/min) and a voltage of 10 kV	Degradation of Rhodamine Blue (RhB) dye	-Larger surface area and narrower band gap - Maximum degradation of 98% was obtained	[133]

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1294 **Table 4:** Photocatalysts doped with various dopants using plasma treatments for energy and other applications.

Types of Plasma	Photocatalyst	Plasma treatment method	Scope	Effects of plasma	Ref.
N ₂ Plasma	N- TiO ₂	DBD plasma reactor used quartz, pressure 1 bar, power frequency 6 kHz, 300 ml/min gas flowrate	Photocatalysis	<ul style="list-style-type: none"> -More oxygen vacancy and Ti³⁺ ions found - Rate of hydrogen evolution found to be 8.1 mmol.h⁻¹.g⁻¹ -Narrower bandgap 	[112]
CH ₄ Plasma	C-doped Co ₃ O ₄	RF (13.65 MHz) plasma	HER and OER	<ul style="list-style-type: none"> -Oxygen vacancies and heteroatom - The plasma treatment enhanced HER - For the same current density, 65% and 26% reduction of overpotential was found for HER and OER respectively 	[71]

N ₂ Plasma	N doped Magnetic WO _{3-x} - @Mesoporous carbon	High DC voltage (1200 V)	H ₂ production and antibiotic degradation	-Larger surface area and band gap reduced to 2.08 eV - The H ₂ production increased to 2765 μmolg ⁻¹ h ⁻¹ - About 90% degradation of antibiotics	[87]
H ₂	Mesoporous black TiO ₂ thin film	TiO ₂ film purged with H ₂ at 100 sccm and in MPCVD system for 10 min at 5 torr pressure	Photoelectrochemical water oxidation	-Scattering length density (SLD) reduction, so, significant H ₂ uptake -Improved interfacial charge transfer and restricted recombination -larger specific surface area	[111]
N ₂ /Ar Plasma	Mesoporous N-TiO ₂ thin film	The sample was placed on the evacuated Mo sample stage, purged with Ar at 100 sccm, and in the MPCVD system, varying N ₂ flowrates	Photoelectrochemical water oxidation	-Enhancement of photocurrents (up to 80-240 times) -Significant enhancement of water oxidation (up to a maximum of 7 times) -Bandgap reduction from 3.5 to 2.88 eV	[44]

N ₂ plasma	N-Cu ₂ O/CuO	Nano-catalyst powder inside a plasma chamber with N ₂ flow rate at 50 sccm and 100 Pa	H ₂ O ₂ generation	<ul style="list-style-type: none"> -No need for precious metal or organic scavengers -Improved charge separation ability -CuO on the surface acts as an active site for more photo-generated electrons -3 and 8 times more H₂O₂ production was obtained with plasma treated N-Cu₂O/CuO compared to Cu₂O and CuO, respectively. 	[45]
N ₂ plasma	Fe: ZnO nanowires	Chemical vapor deposition chamber used with plasma power 500 W for 10 min	Photoelectrochemical, photovoltaic, photo-response of ZnO wires	<ul style="list-style-type: none"> -Increased photoconductivity of the film -bandgap reduction from 3.261 to 3.25 eV -The presence of a high density of shallow donor states -Reshape the conduction band -Passivation of oxygen vacancy -Dissociation of weakly bonded nanowires -Reduction of the density of nanowire surface area 	[113]